



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **TANIGUCHI, et al.**

Group Art Unit: **2827**

Serial No.: **09/836,182**

Examiner: **MITCHELL, James M.**

Filed: **April 18, 2001**

P.T.O. Confirmation No.: 7961

For. **METHOD OF FABRICATING SEMICONDUCTOR HAVING THROUGH HOLE**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
Washington, D.C. 20231

Date: February 11, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated August 13, 2002 for three months from November 13, 2002 to February 13, 2003.

Please note that a one-month extension of time was filed in the U.S. Patent and Trademark Office on November 22, 2002. Attached please find a check in the amount of \$820.00 to cover the cost of the difference for an extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.


Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

02/12/2003 BABRAHA1 00000077 09836182

01 FC:1253

820.00 DP


William G. Kratz, Jr.
Attorney for Applicant
Reg. No. 22,631

WGK/nrp

Atty. Docket No. **980931B**
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930



23850

PATENT TRADEMARK OFFICE

RECEIVED
FEB 13 2003
TECHNOLOGY CENTER
23800